
A COMPACT MODEL FOR SPHERICAL ROUGH CONTACTS

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OVERVIEW



- Introduction
- Objectives
- Present Model
- General Pressure Distribution
- Dimensional Analysis
- Comparison with Experimental Data
- Conclusions

INTRODUCTION

Contact of Spheres

- elastic, smooth
 - Hertz (1881) theory of elastic contact of spheres

$$P_{Hz} \quad r/a_{Hz} \quad P_{0,HZ} \sqrt{1 - r/a_{Hz}}^2$$

- elastic, rough spheres, elastic microcontacts
 - Greenwood and Tripp (1967)

- plastic, rough surfaces, plastic microcontacts
 - Mikic and Roca (1974)

- roughness parameter $\alpha = \frac{\sigma \rho}{a_H^2} = \sigma \left(\frac{16\rho E'^2}{9F^2} \right)^{1/3}$
 - Greenwood et al. (1984)

OBJECTIVES

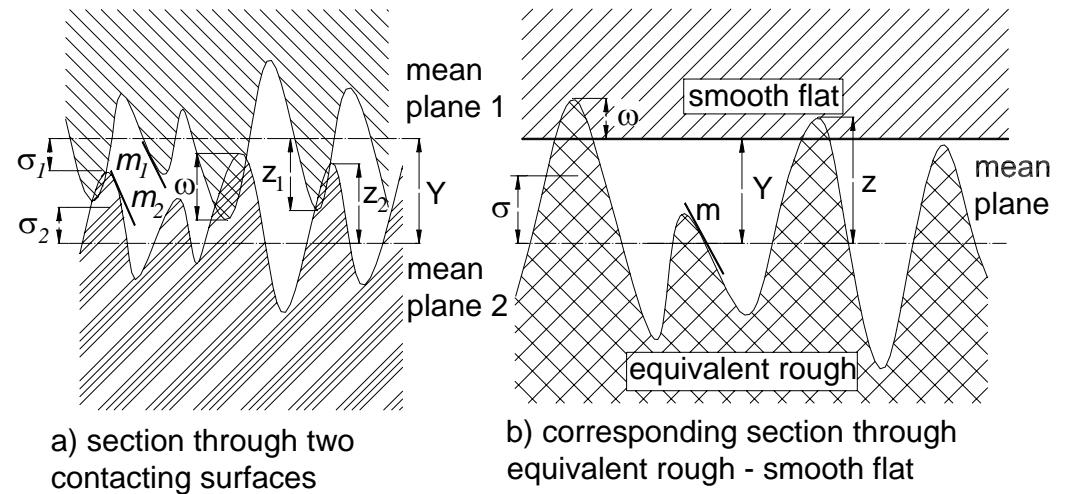


- develop model to predict the parameters of spherical contact:
 - pressure distribution,
 - elastic deformation,
 - compliance,
 - number of microcontacts,
 - size of the contact area

- derive simple correlations for determining contact parameters that can be used in other analyses such as thermal contact models

conforming rough contacts Plastic Model

- Gaussian surfaces
- plastically deformed hemispherical asperities
- cross-level theory



$$Y/\sqrt{2}$$

$$\frac{A_r}{A_a} = \frac{1}{2} \operatorname{erfc}$$

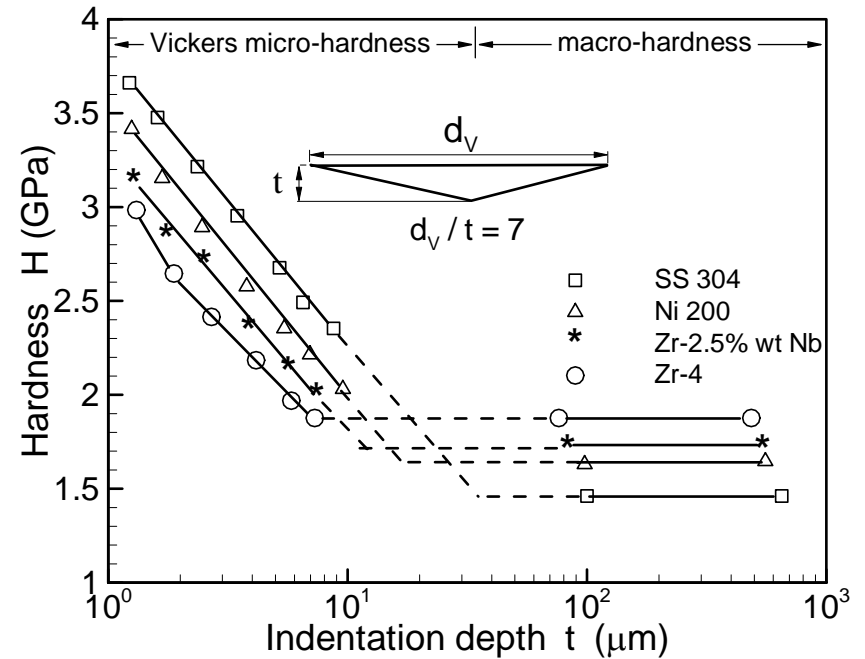
$$a_s = \sqrt{\frac{8}{m}} \exp^{-2} \operatorname{erfc}$$

$$n_s = \frac{1}{16} \frac{m}{2} \frac{\exp(-2^2)}{\operatorname{erfc}} A_a$$

MICROHARDNESS

Hegazy (1985)

- microhardness may not be constant throughout the material as a result of machining process
- microhardness decreases with increasing depth of indentation until bulk hardness level

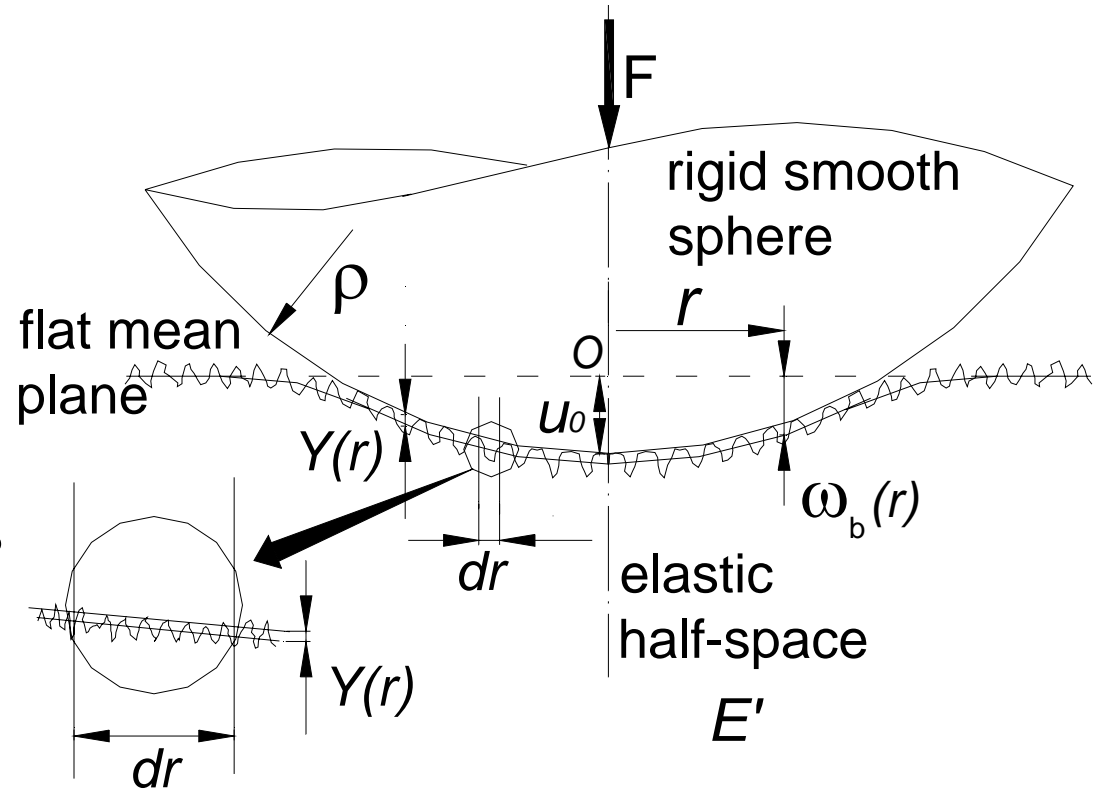


$$H_v = c_1 d_v^{-c_2}$$

$$d_v = d_v / d_0$$

PRESENT MODEL: ASSUMPTIONS

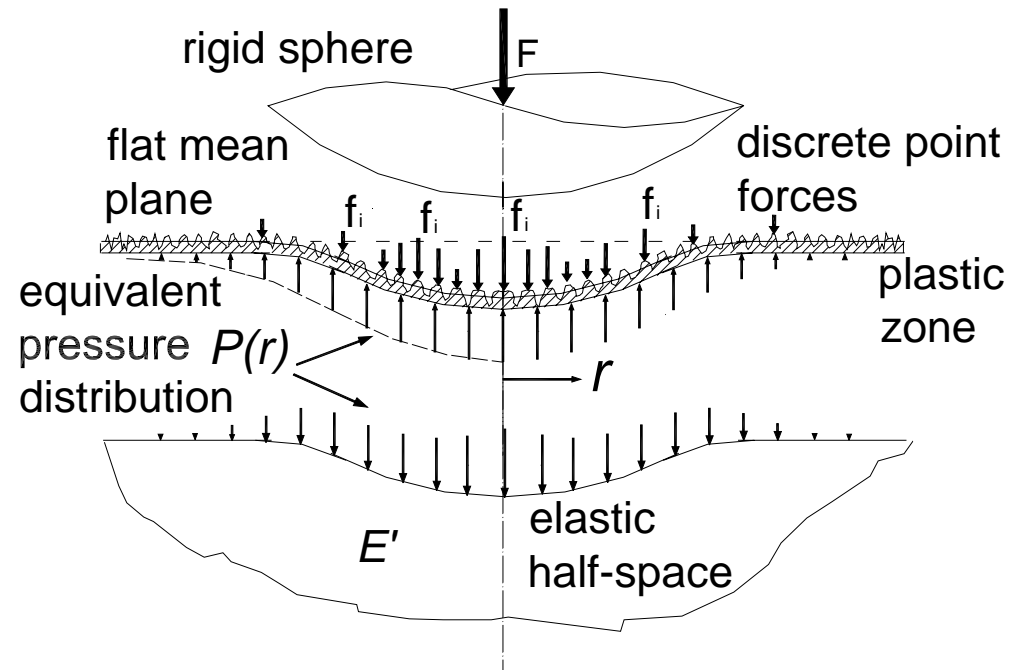
- spherical surfaces
- Gaussian asperity distribution
- plastic microcontacts
- elastic macrocontact



$$Y(r) = w_b(r) - u(r) = w_b(r) - u_0 + r^2/2\rho$$

ASSUMPTIONS 2

- deformation of each asperity is independent of its neighbors
- no friction
- first loading cycle
- static contact



RELATIONSHIPS FOR MECHANICAL MODEL

dimensionless local separation $\lambda(r) = Y(r) / (\sqrt{2}\sigma)$

effective pressure distribution $P(r) = \frac{1}{2} H_{mic}(r) \operatorname{erfc}(\lambda(r))$

elastic deformation of half-space due to applied P(r)

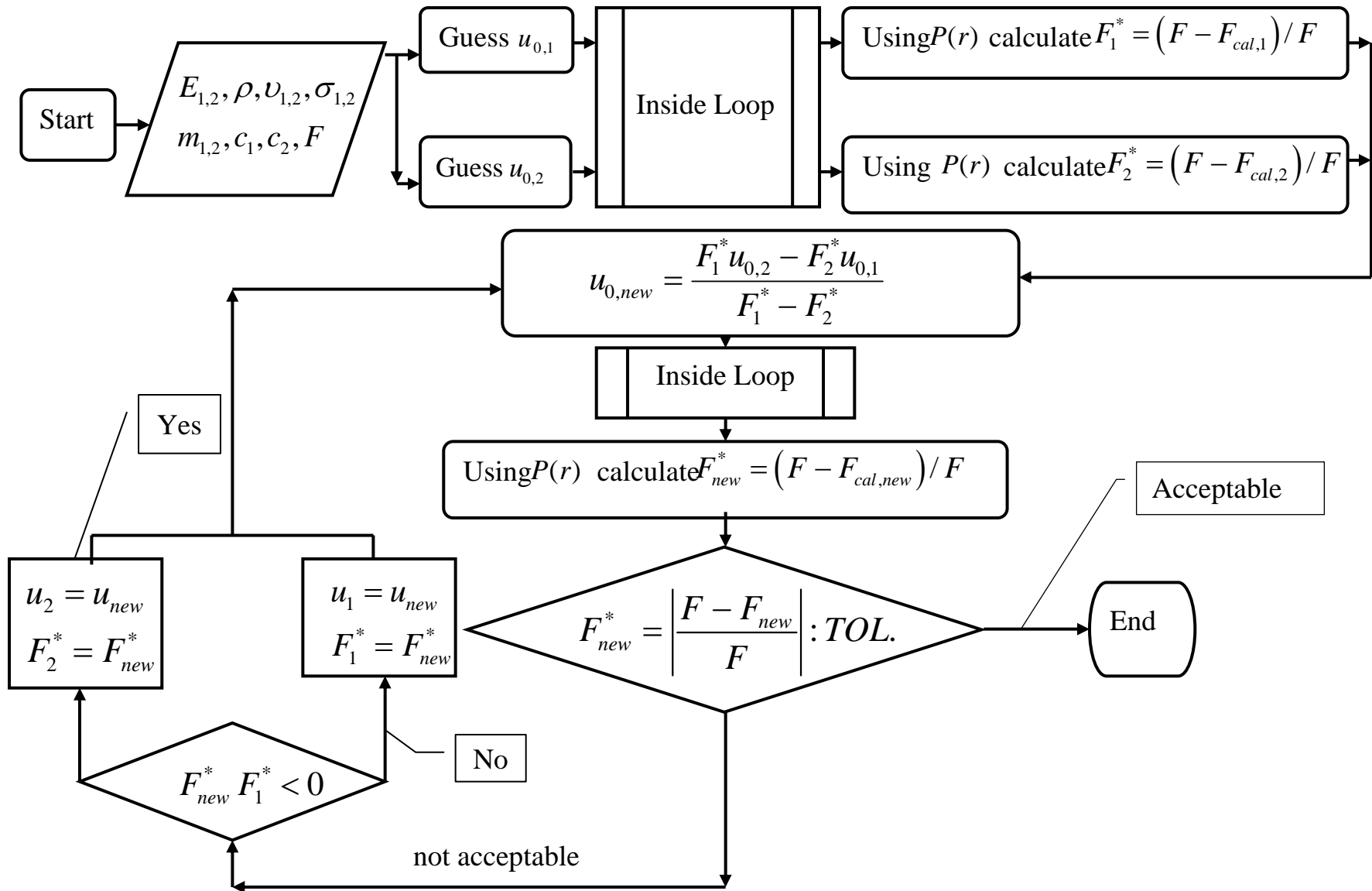
$$\omega_b(r) = \begin{cases} \frac{2}{E^*} \int_0^\infty P(s) ds & r = 0 \\ \frac{4}{\pi E^* r} \int_0^r s P(s) K\left(\frac{s}{r}\right) ds & r > s \\ \frac{4}{\pi E^*} \int_r^\infty P(s) K\left(\frac{r}{s}\right) ds & r < s \end{cases} \quad \frac{1}{E^*} = \frac{1-\nu_1^2}{E_1} + \frac{1-\nu_2^2}{E_2}$$

force balance $F = 2\pi \int_0^\infty P(r) r dr$

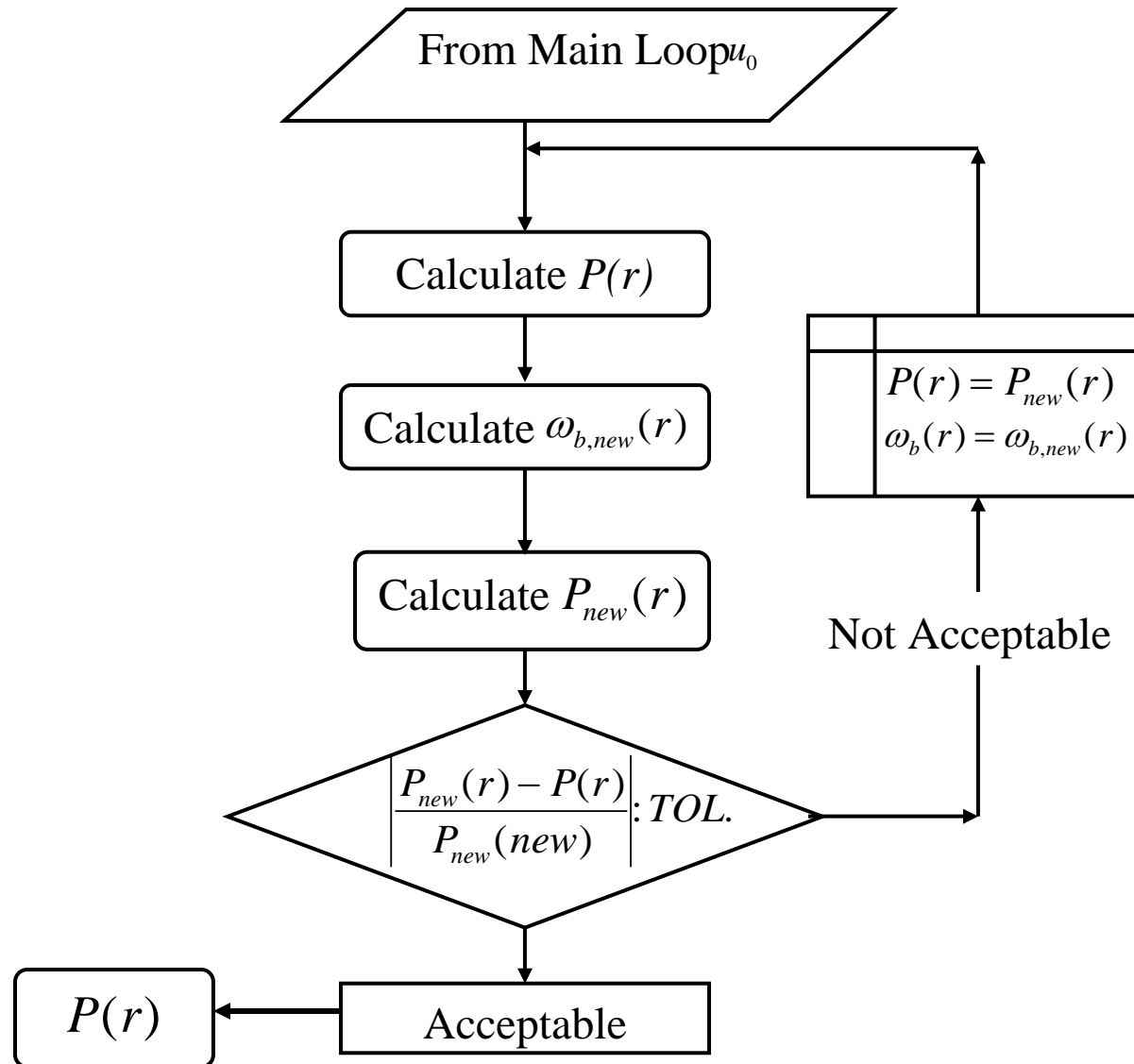
local microcontact radius $a_s(r) = \sqrt{\frac{8}{\pi}} \left(\frac{\sigma}{m}\right) \exp(\lambda^2(r)) \operatorname{erfc}(\lambda(r))$

local microhardness $H_{mic}(r) = c_1 \left(\sqrt{2\pi} a_s(r)\right)^{c_2}$

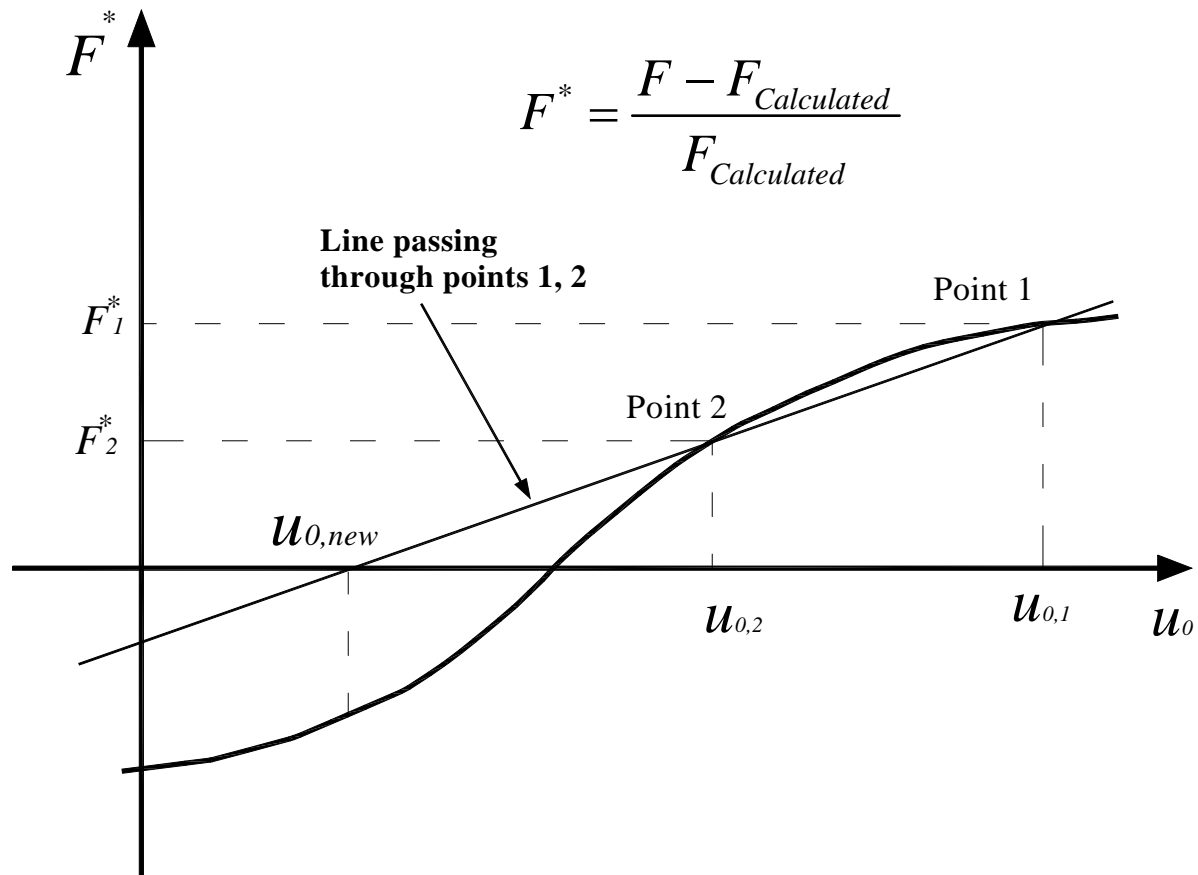
NUMERICAL ALGORITHM – MAIN LOOP



NUMERICAL ALGORITHM – INSIDE LOOP



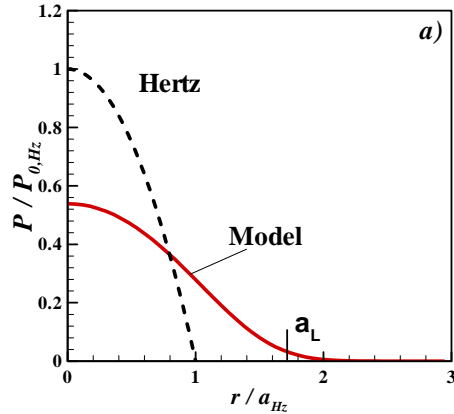
SUCCESSIVE ITERATION



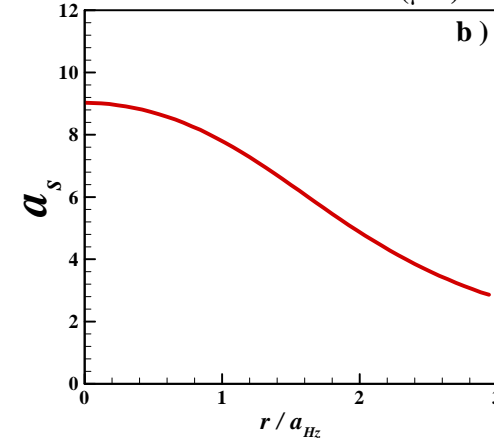
OUTPUT PARAMETERS OF MODEL

Radius of curvature	$\rho = 25(mm)$	Roughness	$\sigma = 1.414(\mu m)$	Force	$F = 50(N)$
Surface slope	$m = 0.107$	Young's modulus	$E_1 = E_2 = 204(GPa)$	Poisson's	$\nu_1 = \nu_2 = 0.3$
Microhardness	$c_1 = 6.27(GPa)$	Microhardness	$c_2 = -0.15$	Sample dia.	$b_L = 25(mm)$

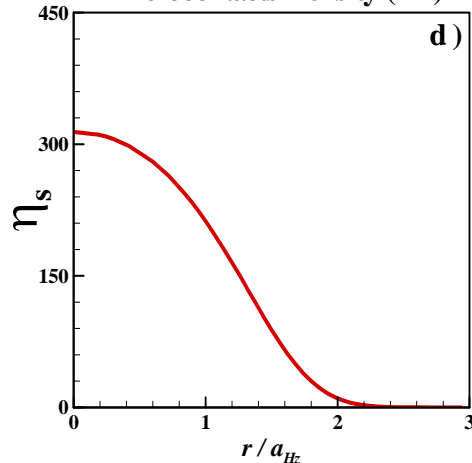
Non-Dimensional Pressure Distribution



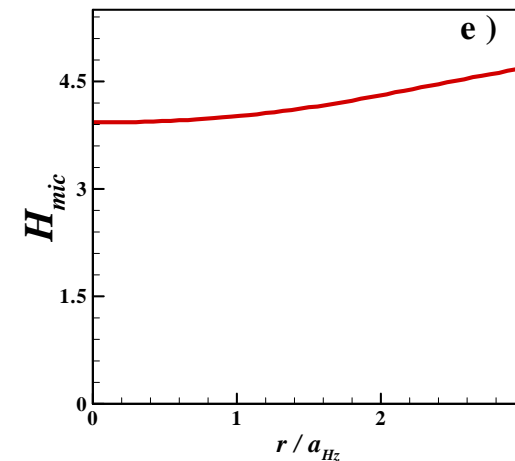
Microcontacts Radius (μm)



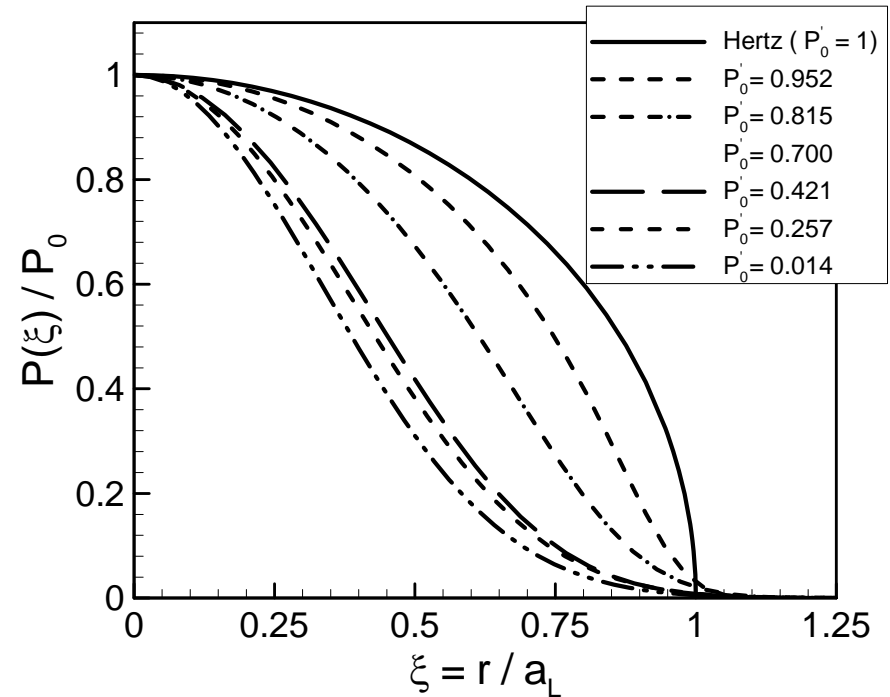
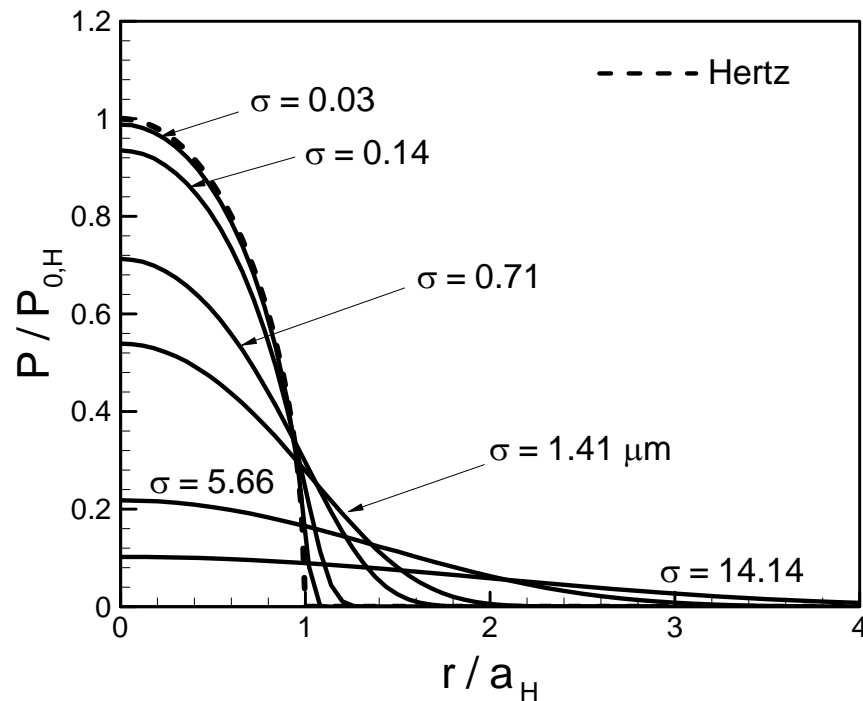
Microcontacts Density (m^{-2})



Microhardness (GPa)



GENERAL PRESSURE DISTRIBUTION



$$P(\xi) = P_0 (1 - \xi^2)^\gamma$$

$$\gamma = 1.5 \frac{P_0}{P_{0,H}} \left(\frac{a_L}{a_H} \right)^2 - 1$$

$$P_0 = (1 + \gamma) \frac{F}{\pi a_L^2}$$

Hertzian limit

$$P_H(r/a_H) = P_{0,H} (1 - (r/a_H)^2)^\gamma$$

$$\gamma_H = 0.5$$

$$P_{0,H} = \frac{1.5F}{\pi a_H^2}$$

DIMENSIONAL ANALYSIS



- effective microhardness,

$$H_{mic} = \text{Const.}$$

- surface slope m is assumed to be a function of surface roughness, Lambert (1995)

$$m = 0.076 \rho^{0.52}$$

- maximum contact pressure is a function of

$$P_0 = P_0, E, F, H_{mic}$$

- three non-dimensional parameters

Parameter	Dimension
Effective elastic modulus, E	$ML^{-1}T^{-2}$
Force, F	MLT^{-2}
Microhardness, H_{mic}	$ML^{-1}T^{-2}$
Radius of curvature,	M
Roughness,	M
Max. contact pressure, P_0	$ML^{-1}T^{-2}$

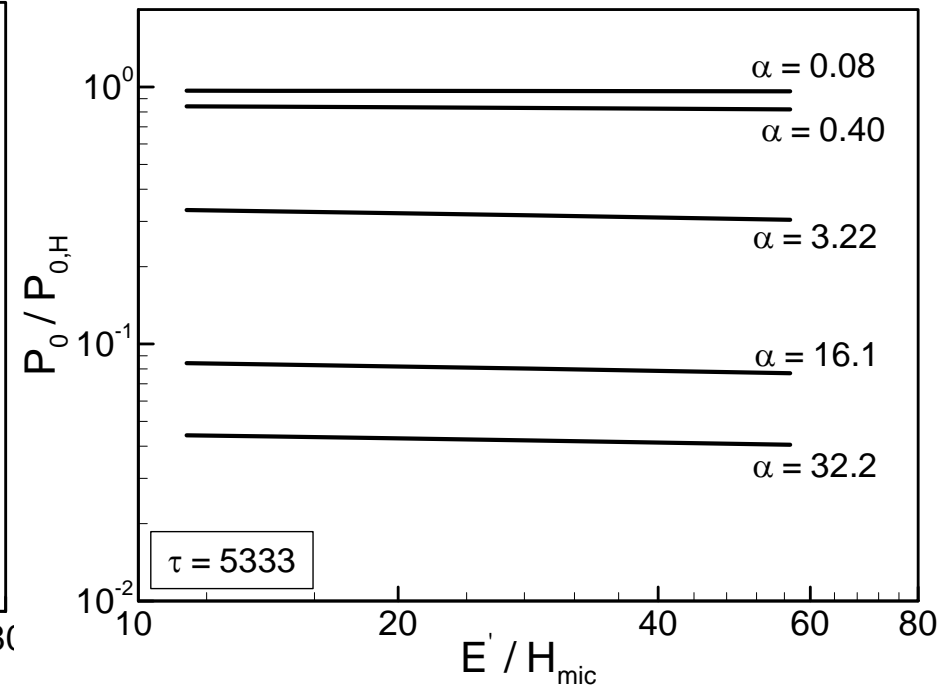
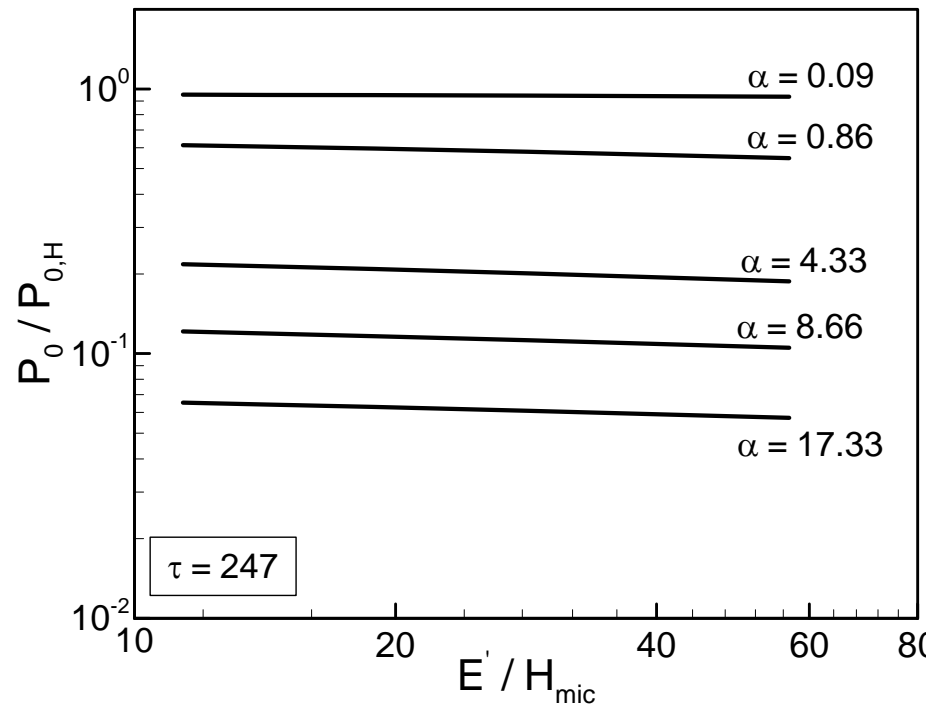
$$\alpha = \frac{\sigma}{\omega_{0,H}} \equiv \frac{\sigma \rho}{a_H^2}$$

$$\tau = \frac{\rho}{a_H}$$

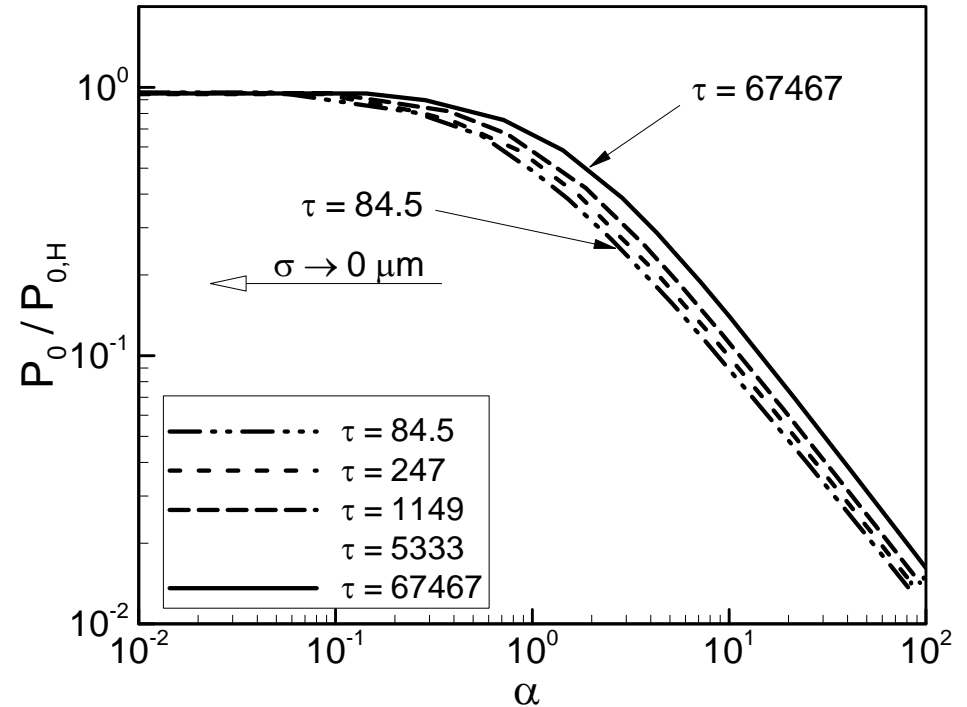
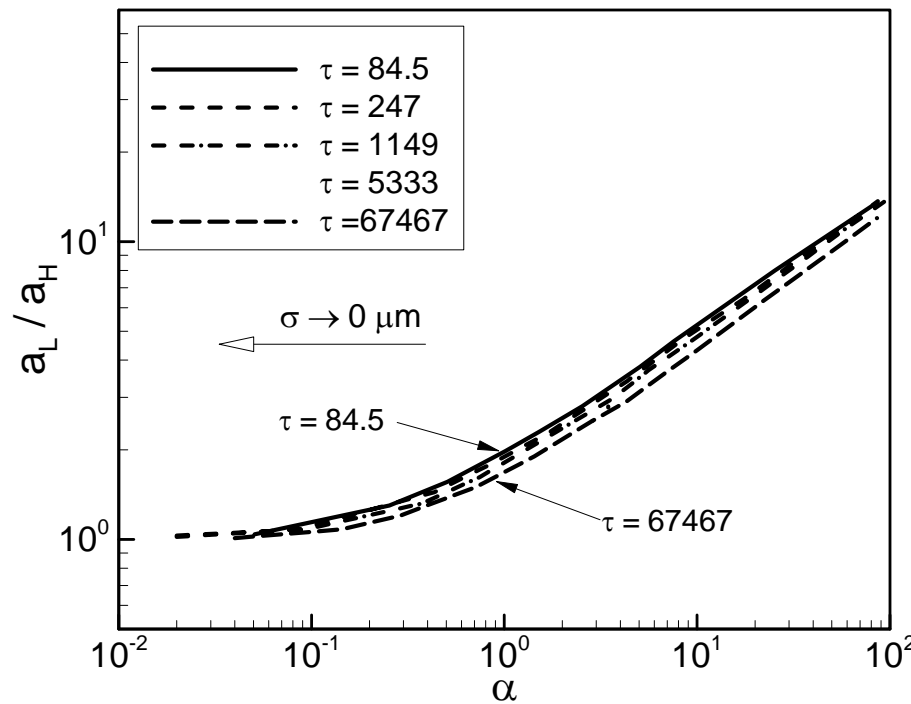
$$E = \frac{E}{H_{mic}}$$

EFFECT OF MICROHARDNESS PARAMETER

effect of microhardness parameter on the maximum contact pressure is small and therefore ignored.



CORRELATIONS



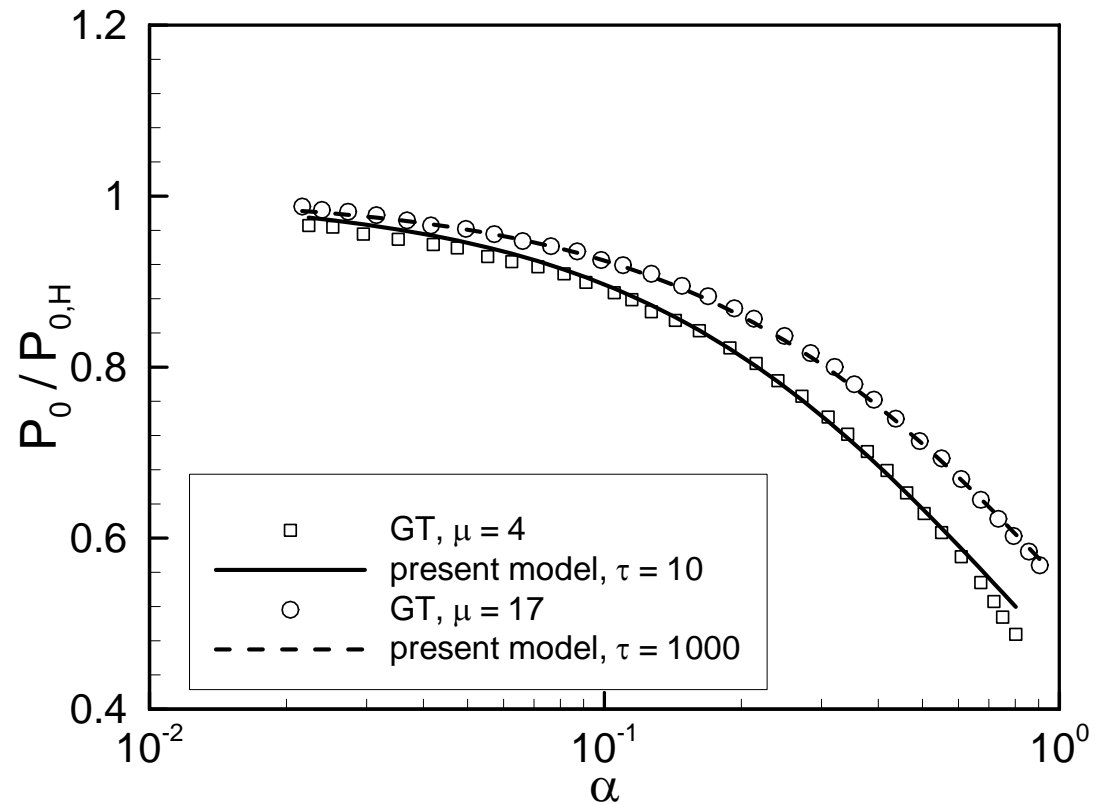
$$P_0' = \frac{P_0}{P_{0,H}} = \frac{1}{1 + 1.37\alpha / \tau^{0.075}}$$

$$a_L' = \frac{a_L}{a_H} = \begin{cases} 1.605 / \sqrt{P_0'} & 0.01 \leq P_0' \leq 0.47 \\ 3.51 - 2.51P_0' & 0.47 \leq P_0' \leq 1 \end{cases}$$

COMPARISON WITH GT MODEL

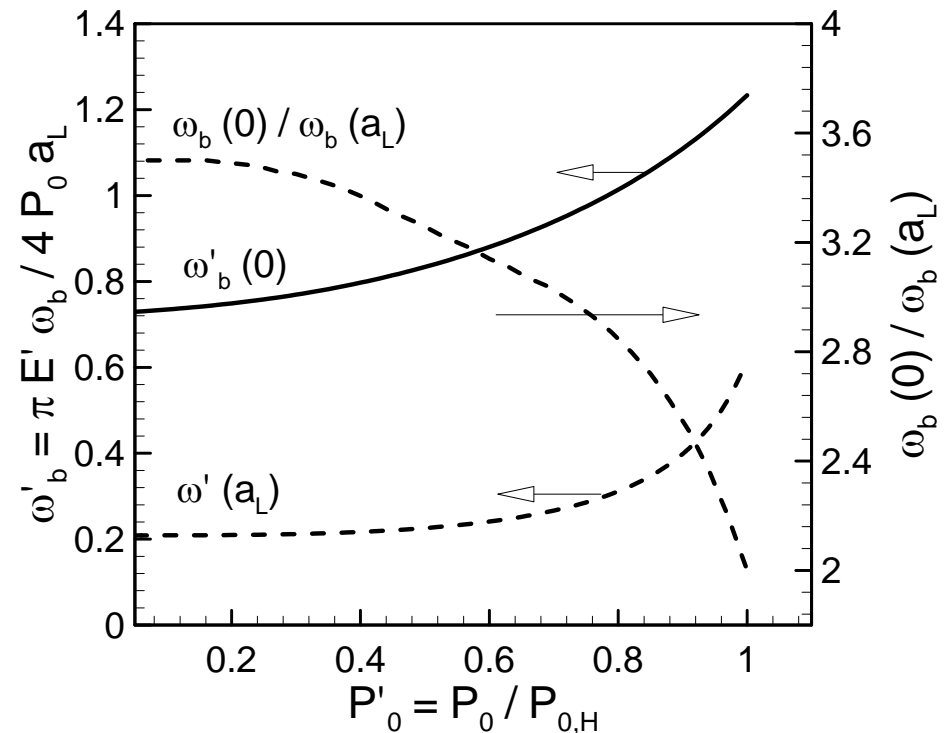
Greenwood and Tripp (1967) disadvantages:

- complex, requires computer programming and numerically intensive solutions
- β and η_s cannot be measured directly, sensitive to the surface measurements
- constant summit radius β is unrealistic

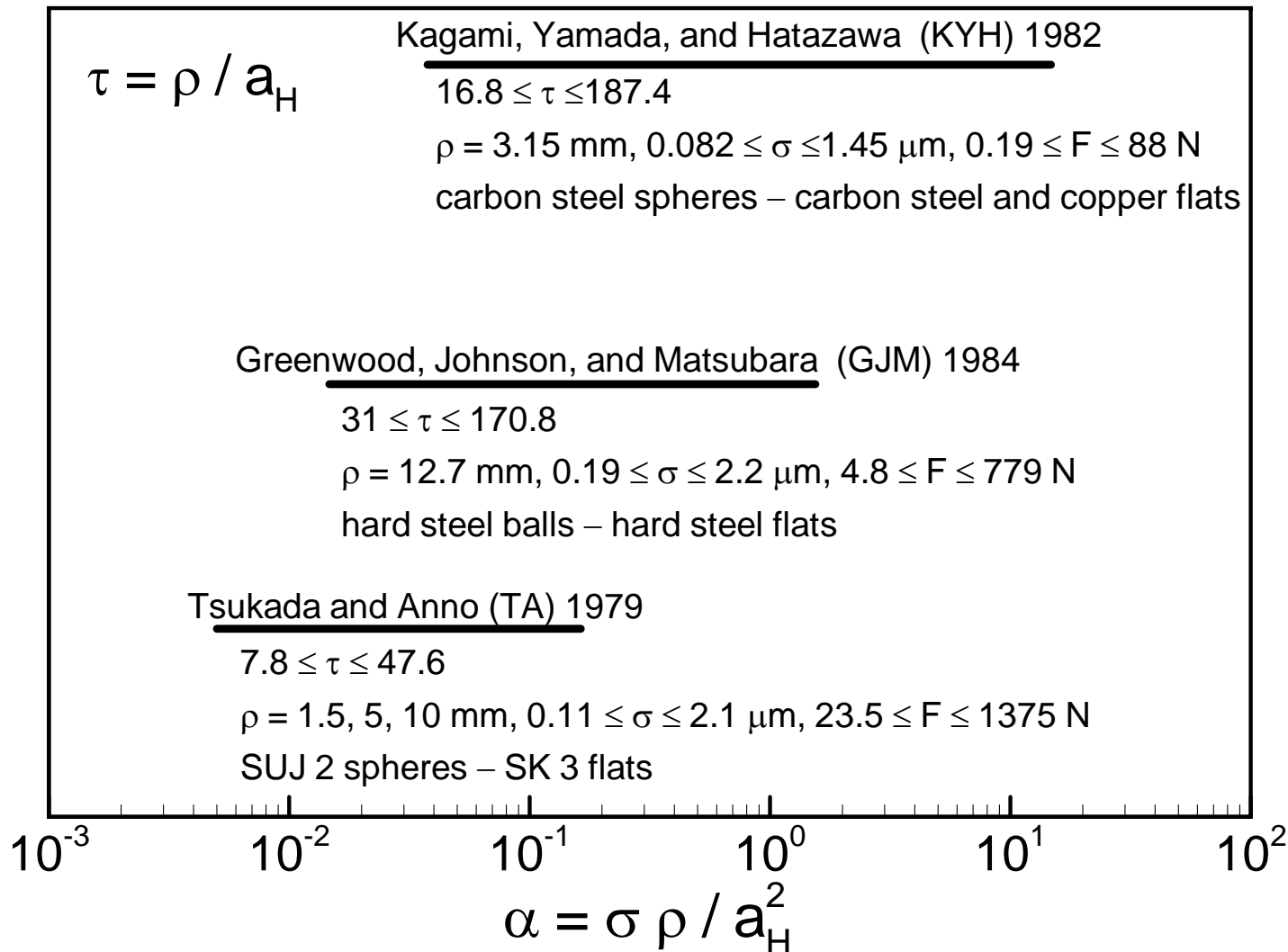


ELASTIC DEFORMATION OF HALF-SPACE

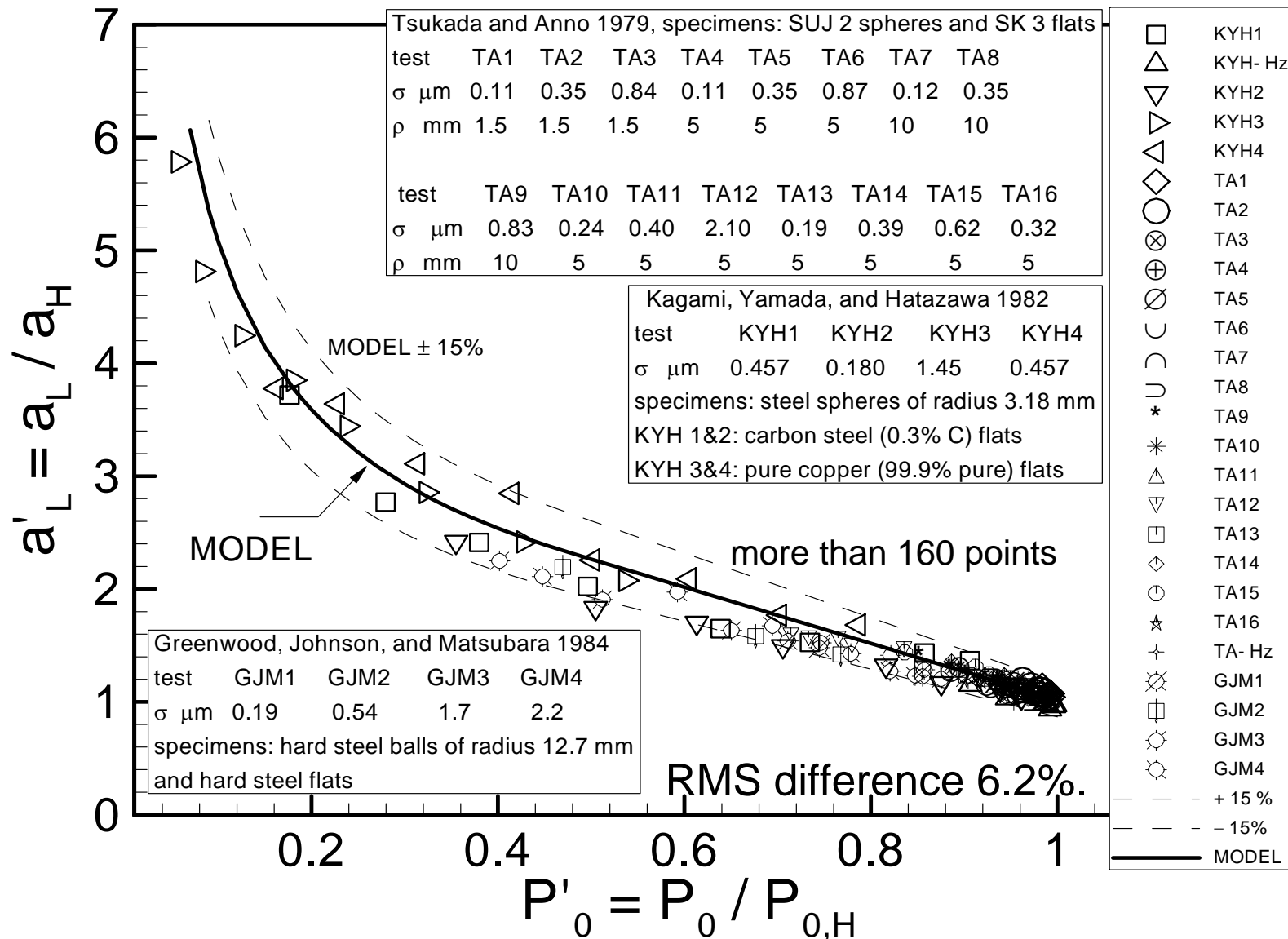
- using general pressure distribution, relationships are derived for:
 - elastic deformation of half-space
 - compact correlation is derived for compliance



EXPERIMENTAL DATA

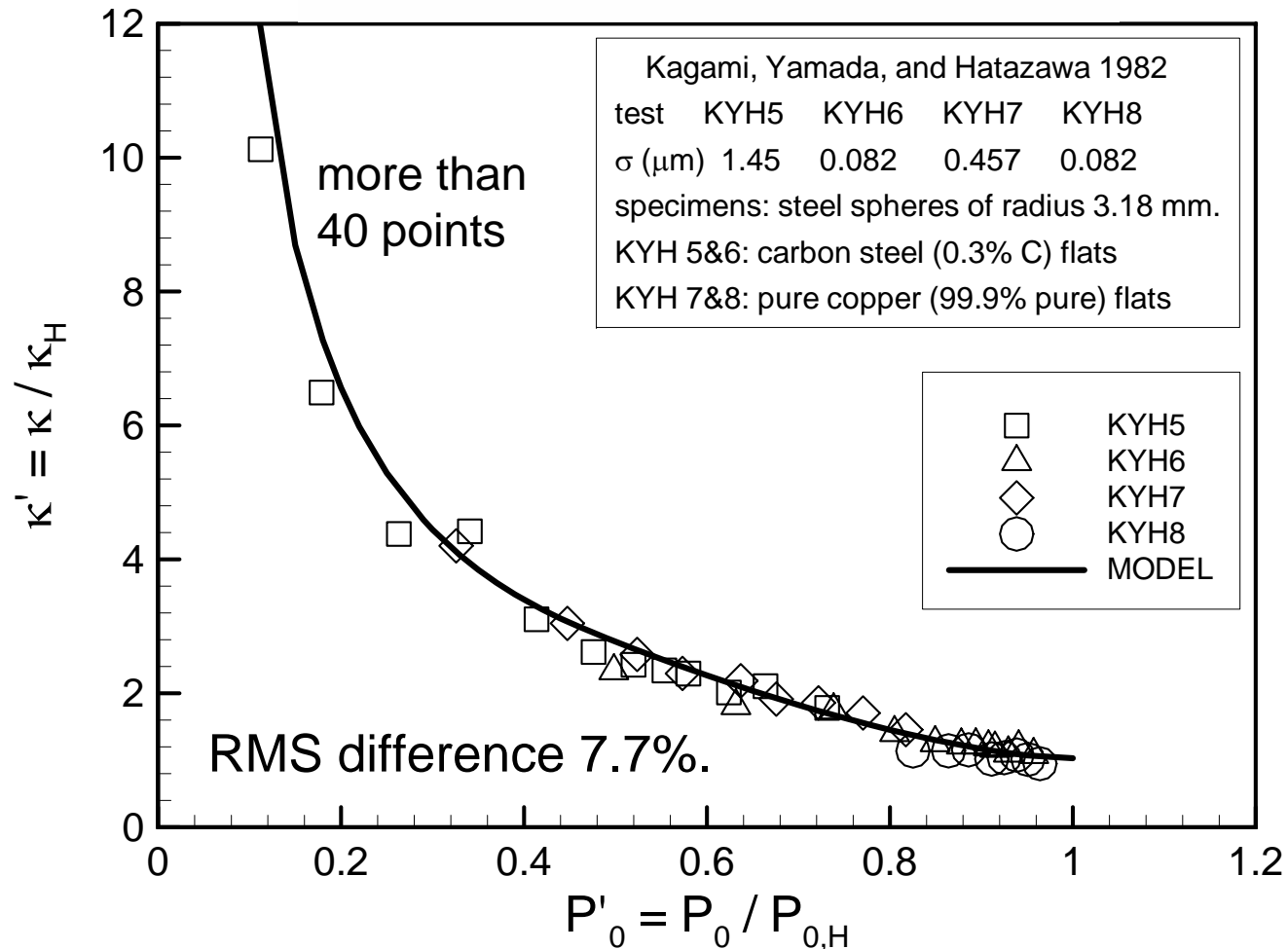


COMPARISON WITH DATA: CONTACT RADIUS



COMPARISON WITH DATA: COMPLIANCE

$$\kappa' = \frac{\kappa}{\kappa_H} = 0.5 (a'_L)^2 + \frac{8P'_0 a'_L}{\pi^2 [4.79 - 3.17 (P'_0)^{3.13}]}$$



SUMMARY AND CONCLUSIONS



- a general pressure distribution that encompasses all spherical rough contacts including Hertzian limit is proposed
- compact correlations for contact radius and compliance are proposed and validated with experimental data
- It is shown that the non-dimensional maximum contact pressure is the main parameter that controls the solution of spherical rough contacts

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